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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Fernando Gonzalez et al.

Serial No.: 10/081,915

Filed: February 22, 2002

For: METHOD FOR FORMING
CONDUCTORS IN A
SEMICONDUCTOR DEVICE

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Group Art Unit: 2814

Examiner: Peralta, Ginette

Atty. Docket: MCRO:125--4/FLE
94-0281.04

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APPEAL BRIEF PURSUANT TO 37 C.F.R. §§ 41.31 AND 41.37

This Appeal Brief is being filed in furtherance to the Notice of Appeal mailed on April 1, 2005, and received by the Patent Office on April 6, 2005.

1. **REAL PARTY IN INTEREST**

The real party in interest is Micron Technology, Inc., the Assignee of the above-referenced application by virtue of the Assignment recorded at reel 7889, frame 0678, and dated February 23, 1996.